



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Masaki Aoki et al.

Serial No.: 09/997,988

Filed: 11.29.2001

For: METHOD OF PRODUCING
PLASMA DISPLAY PANEL WITH
PROTECTIVE LAYER OF AN
ALKALINE EARTH OXIDE

Patent Examiner: Kunemund, Robert M.

Group Art Unit: 1765

September 1, 2004

Irvine, California 92614

**SUPPLEMENTAL
INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, Applicant wishes to bring to the attention of the U.S. Patent Office the following references:

IBM Technical Disclosure Bulletin Vol. 18, No. 6, November 1975, article entitled FABRICATION PROCESS FOR GAS DISCHARGE PANELS

Article entitled EPITAXIAL GROWTH, Part A edited by J.W. Matthews

Article entitled THIN FILM PROCESSES edited by Vossen & Kern

Copies of these references and form PTO-A820 are attached.

Please charge the \$180.00 fee for submission of this Information Disclosure Statement to our Deposit Account No. 19-2814, a copy of this letter is enclosed for that purpose.

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If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patent, PO Box 1450, Alexandria, VA 22313-1450 on September 1, 2004

by: James Lee



Signature

Date of Signature: September 1, 2004

Very truly yours,

SNELL & WILMER LLP



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Reg. No. 25,124

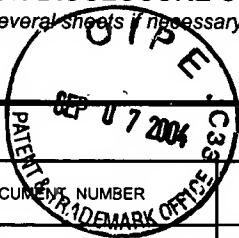
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INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



ATTY DOCKET NO.

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APPLICANT(S)

Masaki Aoki et al.

FILING DATE

November 29, 2001

GROUP

1765

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		IBM Technical Disclosure Bulletin, FABRICATION PROCESS FOR GAS DISCHARGE PANELS by M. Berkenblit et al., Vol. 18, No. 6, November 1975, 2 pages
		EPITAXIAL GROWTH, Part A, edited by JW Matthews, IBM Thomas J. Watson Research Center, New York, Pages 91-99
		THIN FILM PROCESSES, Edited by John L. Vossen and Werner Kern, RCA Laboratories, David Sarnoff Research Center, New Jersey, 1978, Pages 340-341

EXAMINER	DATE CONSIDERED
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.